

AUG 09 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

the application of

Naoaki OGURE et al.

Serial No. 09/866,843

Filed May 30, 2001

COATING, MODIFICATION AND ETCHING
OF SUBSTRATE SURFACE WITH PARTICLE
BEAM IRRADIATION OF THE SAME

: Mail Stop: AMENDMENT

: Confirmation No. 7255

: Docket No. 2001_0686A

: Group Art Unit 1763

: Examiner G.A. GOUDREAU

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of April 7, 2004.

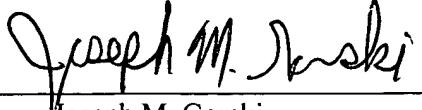
The fee of \$110.00 is

submitted herewith.
 to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.
 Small entity status of this application is established by a Small Entity Status Assertion which
 is enclosed.
 has been previously submitted.

Respectfully submitted,

Naoaki OGURE et al.

By


Joseph M. Gorski
Registration No. 46,500
Attorney for Applicants

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August 9, 2004